

## Certificate of Facsimile Transmission

AUG 10 2005

I hereby certify that the attached Transmittal (1 page), Amendment After Allowance Response to the Notice of Allowance dated May 11, 2005 (5 pages) are submitted to the U.S. Patent and Trademark Office via facsimile number (571) 273-8300 on the date shown below. (Total 9 pages).

  
Li Mei Vermilya

Date: August 10, 2005

PATENT APPLICATION  
Do. No. 4591-383  
Client No. IE10112-US-1

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: You-Cheol SHIN, et al.

Serial No.: 10/777,233

Examiner: Brewster, William M.

Filed:

February 11, 2004

Group Art Unit: 2823

For:

SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME INCLUDING FORMING METAL  
SILICIDE GATE LINES AND SOURCE LINES (as amended)Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Responsive to the Notice of Allowance dated May 11, 2005, enclosed is an amendment in the above-identified application.

The fee has been calculated as shown below.

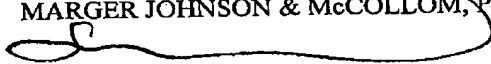
CLAIMS AS AMENDED					
For:	Number After Amendment	Previous Number	Extra	Rate	Additional Fee
Total Claims	5	5	0	x \$50 =	\$0
Independent Claims	2	2	0	x \$200 =	\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0

\*greater of twenty (20) or number for which fee has been paid

\*\*greater of three (3) or number for which fee has been paid

☒ Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

Customer No. 20575

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**AMENDMENT AFTER ALLOWANCE UNDER 37 CFR § 312**

Responsive to the Notice of Allowance, dated May 11, 2005, please amend the application as follows.